

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Schulze, *et al.* Attorney Docket: 2002P50544US  
Filed: January 8, 2004 Examiner: TBD  
Serial No.: 10/753,604 Art Unit: 1762  
Title: Method for the Repair of Defects in Photolithographic Masks for Patterning  
Semiconductor Wafers

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450


**Associate Power of Attorney**

I hereby appoint as associate attorneys of record all of the attorneys and agents at  
Customer Number 25962.

Also please direct all future correspondence to:

Ira S. Matsil  
Slater & Matsil, L.L.P.  
17950 Preston Road, Suite 1000  
Dallas, TX 75252  
(972) 732-1001  
(972) 732-9218 (fax)

Respectfully submitted,

  
Marie-Claire B. Maple  
Attorney of Record  
Reg. No. 37,588

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